INTERNATIONAL GEMOLOGICAL INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

September 11, 2026	
IGI Report Number	LG835644229
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	6.30 - 6.35 X 4.01 MM

GRADING RESULTS

Carat Weight	1.01 CARAT
Color Grade	D
Clarity Grade	VS 1
Cut Grade	EXCELLENT

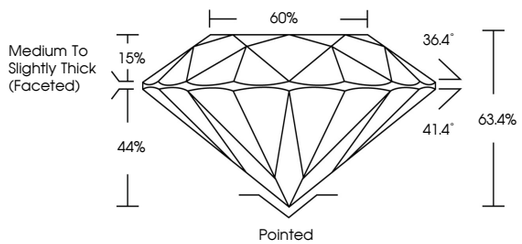
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	IGI LG835644229

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG835644229
Report verification at igi.org

PROPORTIONS



Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

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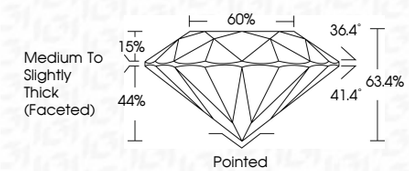

ADDITIONAL GRADING INFORMATION
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IGI

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ROUND BRILLIANT
6.30 - 6.35 X 4.01 MM
Carat Weight 1.01 CARAT
Color Grade D
Clarity Grade VS 1
Cut Grade EXCELLENT
Depth 63.4%
Table 60%
Girdle Medium To Slightly Thick (Faceted)
Culet Pointed
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) IGI LG835644229
Comments:
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Type IIa